



COMPANY BIO

Hyungjun Kim, Ph.D.

*Manager, Advanced Technology
Engagement for Post-CMP Technology*

Dr. Kim joined Entegris in April of 2014 as part of the ATMI acquisition. He has 20 years of experience in the semiconductor industry and currently serves on the customer engagement team for advanced technology development. He is responsible for global technical support for post-CMP products, pad conditioners, CMP filters and post-CMP brushes for advanced nodes.

Dr. Kim was previously responsible for post-CMP technical support for North America and Korea at Entegris before entering his current role. At ATMI, he provided post-CMP technical support in critical global regions.

Before joining ATMI, he worked at Fujifilm Planar Solutions where he was responsible for slurry development, application/technical support and marketing. While there, he developed the top-selling copper slurry and received a patent as first inventor. Prior to that, he worked at SK Hynix in CMP process development.

Dr. Kim received his Ph.D. in material science from the Max Planck Institute for Metal Research/University Stuttgart in Stuttgart, Germany.